

Application/Control No.	Applicant(s)/Patent under Reexamination
10/563,002	FREDERIKSEN ET AL.
Examiner	Art Unit
Hieu P. Nguyen	2817

SEARCHED					
Class	Subclass	Date	Examiner		
330	10	1/11/2008	HN		
330	207A	1/11/2008	HN		
330	251	1/11/2008	HN		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
US-PGPUB		1/11/2008	HN		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
MOTTOLA STEVEN J	1/9/2008	HN	